

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: H. Kitsunai, et al.
Application No.: Rule 53(b) of No. 09/946,507
Filed: April 16, 2004
For: PROCESS FOR PRODUCING SEMICONDUCTOR DEVICE
Expected
Group: 2822
Expected
Examiner: K. Duong

CLAIM FOR PRIORITY

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 16, 2004

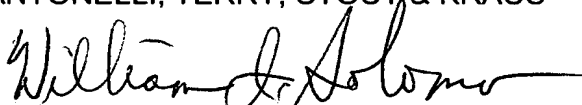
Sir:

Pursuant to the provisions of 35 U.S.C. § 119 and 37 CFR §1.55, Applicants hereby claim the right of priority based on Japanese Patent Application No. 2001-253099, filed in Japan on August 23, 2001.

A certified copy of the above-identified Japanese patent application was submitted on October 30, 2001, in prior Application No. 09/946,507, filed September 6, 2001.

Respectfully submitted,

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WIS/sjg